Docket No.: 060188-0594

PATENT

ATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Shuji HIRAO

Confirmation Number: 6629

Application No.: 10/624,564

Group Art Unit: 1753

Filed: July 23, 2003

Examiner: WONG, Edna

For: METHOD AND APPARATUS FOR PLATING SUBSTRATE

DEC 28 2006

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

| | NO. OF CLAIMS | HIGHEST PREVIOUSLY PAID FOR | EXTRA CLAIMS | RATE | FEE |
|---------------------------|------------------|---|-----------------|------------|--------|
| Total Claims | 16 | 30 | 0 | \$50.00 = | \$0.00 |
| Independent Claims | 2 | 4 | 0 | \$200.00 = | \$0.00 |
| | | Multiple dependent claims newly presented | | | \$0.00 |
| Fee for extension of time | | | | \$0.00 | |
| | | | | | \$0.00 |
| | | Total of Above Calculations | | | \$0.00 |

Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of \boxtimes extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Foe Registration No. 36,139

Please recognize our Customer No. 20277 as our

correspondence address.

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Facsimile: 202.756.8087 Date: December 28, 2006



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 28, 2006, having a three-month shortened statutory period for response set to expire December 28, 2006, please amend the above-identified application as follows.